

**Notice of References Cited**

Application/Control No.

09/752,099

Applicant(s)/Patent Under  
Reexamination  
CONNOR ET AL.

Examiner

Kim T. Huynh

Art Unit

2189

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*	B	US-6,567,882	05-2003	Onagawa, Seiki	710/314
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**NON-PATENT DOCUMENTS**

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